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To:	Examiner C.Q. Nguyen	From:	Leslie S. Szivos, Ph.D.
Fax:	703 872-9306	Pages:	1 Including cover sheet
Phone:		Date:	12/14/2004
Re:	US Application Serial No. 10/700,085 Filing Date: 11/03/2003 Docket No. YOR920030586US1 (17201)		
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Attached hereto is:

1. Response Under 37 C.F.R. §1.111 and §1.143
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CERTIFICATE OF TRANSMISSION BY FACSIMILE (37 CFR 1.8)

Applicant(s): Tze-Chiang Chen, et al.

Docket No.

Y0R920030586US1 (17201)

Application No.
10/700,085Filing Date
11/3/2003Examiner
C.Q. NguyenGroup Art Unit
2811Invention: **METHOD FOR FABRICATING SiGe-ON-INSULATOR (SGOI) AND Ge-ON-INSULATOR (GOI) SUBSTRATES**I hereby certify that this RESPONSE UNDER 37 CFR §1.111 AND §1.143
(Identify type of correspondence)is being facsimile transmitted to the United States Patent and Trademark Office (Fax. No. 703-872-9306)on December 14, 2004
(Date)Leslie S. Szivos, Ph.D. Registration No. 39,394
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(Signature)

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TRANSMITTAL LETTER
(General - Patent Pending)

Docket No.
Y0R920030586US1 (17201)

In Re Application Of: **Tze-Chiang Chen, et al.**

Application No. 10/700,085	Filing Date 11/3/2003	Examiner C.Q. Nguyen	Customer No. 23389	Group Art Unit 2811	Confirmation No. 2805
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Title: **METHOD FOR FABRICATING SiGe-ON-INSULATOR (SGOI) AND Ge-ON-INSULATOR (GOI) SUBSTRATES**

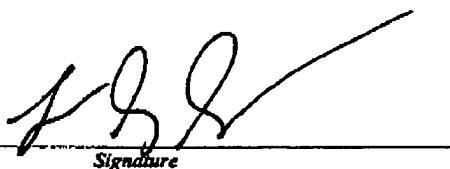
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Response Under 37 C.F.R. §1.111 and §1.143

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- A check in the amount of _____ is attached.
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 Registration No. 39,394

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TRANSMITTAL LETTER
(General - Patent Pending)

Docket No.
Y0R920030586US1 (17201)

In Re Application Of: **Tze-Chiang Chen, et al.**

Application No.	Filing Date	Examiner	Customer No.	Group Art Unit	Confirmation No.
10/700,085	11/3/2003	C.Q. Nguyen	23389	2811	2805

Title: METHOD FOR FABRICATING SiGe-ON-INSULATOR (SGOI) AND Ge-ON-INSULATOR (GOI) SUBSTRATES

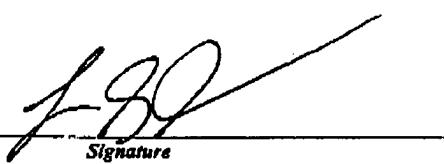
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